



AF/IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **IZUMI, Katsutoshi, et al.**

Group Art Unit: **2815**

Serial No.: **10/699,832**

Examiner: **Jerome Jackson, Jr.**

Filed: **November 4, 2003**

P.T.O. Confirmation No.: 5574

**FOR: MONOCRYSTALLINE GALLIUM NITRIDE LOCALIZED SUBSTRATE AND
MANUFACTURING METHOD THEREOF**

RESPONSE UNDER 37 CFR §1.116
- EXPEDITED RESPONSE -
GROUP ART UNIT 2815

MAILSTOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

October 6, 2005

Sir:

In response to the final Office Action dated **July 7, 2005**, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.